


<b>Search Notes</b>  	<b>Application/Control No.</b>  10642203	<b>Applicant(s)/Patent Under Reexamination</b>  ENOMOTO ET AL.
	<b>Examiner</b>  Rutkowski, Jeffrey	<b>Art Unit</b>  2419

SEARCHED			
Class	Subclass	Date	Examiner
370	216, 254-258 (updated search)	01/08/2009	JMR
709	223, 224 (updated search)	01/08/2009	JMR

SEARCH NOTES		
Search Notes	Date	Examiner

INTERFERENCE SEARCH			
Class	Subclass	Date	Examiner
370	256, 258 (see attached notes)	01/09/2009	JMR
709	224 (see attached notes)	01/09/2009	JMR

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